Venus Series
Line of Low Cost Plasma Cleaners

Designed for universities as well as R&D and production facilities, the Venus series offers fully automatic system control and process sequencing capabilities. Computer control with Plasma Etch, Inc. software enables features such as multiple recipe storage, data logging/trending, events/alarms, and multi-step sequencing while the processing area accommodates numerous parts/sizes. Additional features include mass flow controllers, process data acquisition and archiving, and dual sequence programming. The Venus series includes the Venus-25, Venus-50, Venus-50XL, and Venus-75.

STANDARD FEATURES

- PC-Based Control System
- Process Data Acqusition
- Process Data Archiving
- Dual Sequence Programming
- Hardcopy Process Data Recording
- On-Screen Process Trend Plotting